

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **Takashi OZAKI, et al.**

Serial Number: **Not Yet Assigned**
(§371 of International Application PCT/JP04/01996)

Filed: **March 17, 2005**

For: **SUBSTRATE PROCESSING APPARATUS AND METHOD FOR
MANUFACTURING A SEMICONDUCTOR DEVICE**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

March 17, 2005

Sir:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; International Search Report

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INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 050161	Serial No. New Application
	Applicant(s): Takashi OZAKI, et al.	
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U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

	Document No.	Date	Country	Translation (Yes or No)
_____	AE	2002-110562	04/12/02	Japan Cited in the International Search Report
_____	AF	8-115883	05/07/96	Japan Cited in the International Search Report
_____	AG	2000-223432	08/11/00	Japan Cited in the International Search Report
_____	AH	2002-280373	09/27/02	Japan Cited in the International Search Report
_____	AI			

OTHER DOCUMENTS

_____	AJ	
_____	AK	

Examiner Date Considered